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PATENT APPLICATION

**RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 2814**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroyuki TOMIMATSU

Group Art Unit: 2814

Application No.: 10/782,810

Examiner: H. PHAM

Filed: February 23, 2004

Docket No.: 114371.01

For: SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING THE
SAME, CIRCUIT SUBSTRATE AND ELECTRONIC APPARATUS

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the January 12, 2006, Office Action, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.